IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Krulik, et al.

Serial No. 09/894,274

Filed: June 27, 2001

Title: METHOD OF TREATING

SEMICONDUCTOR WASTE WATERS

Examiner: Unassigned

Art Unit: 1723

San Francisco, CA 94111

Date: February 15, 2002

COPY OF PAPETILED

RECEIVED

MAR 2 6 2002

Technology Center 2100

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being sent via first class mail, postage prepaid in an envelope addressed to: Box Missing Parts, Assistant Commissioner for Patents, Washington, D.C. 20231 on

February 15, 200 Signed:

Kari Bateman

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents Washington, DC 20231

Sir:

Pursuant to 37 C.F.R. 1.136(a), an extension of time of:

	Large Entity	Small Entity
One Month	//\$110.00	/ / \$ 55.00
Two Months	//\$400.00	// \$ 200.00
Three Months	//\$920.00	// \$ 460.00
Four Months	//\$1,440.00	/X/ \$ 720.00
Five Months	//\$1,960.00	// \$ 980.00

is hereby requested to:

/X/ respond to the Notice of Missing Parts mailed <u>August 17, 2001</u>; the requisite fee pursuant to 37 C.F.R. 1.17 is:

/X/ enclosed by Check / / to be charged to Deposit Account No. 06-1300 (Order No. <u>A-68835/MSS</u>).

/X/ Please charge any additional fees or credit any overpayment to Deposit Account No. 06-1300 (Order No. <u>A-68835/MSS</u>).

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720.00 OP

Respectfully submitted

Maria S. Swiatek, Reg. No. 37,244

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